



AFV
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PATENT
81877.0012
Customer No. 26021

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Seiyo NAKASHIMA, et al.
Serial No: 09/816,643
Confirmation No: 6862
Filed: March 23, 2001
For: Substrate Processing Apparatus
and Substrate Processing Method

Art Unit: 1763
Examiner: Kackar, Ram N.

PETITION FOR EXTENSION OF TIME

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

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October 25, 2005

Date of Deposit

Juanita Soberanis

Name

Juanita Soberanis 10/25/2005

Signature

Date

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a five-month extension of time extending to October 25, 2005, from which a Notice of Appeal was filed on March 25, 2005 in response to the Final Office Action dated September 27, 2004. The extension is sought for the purpose of maintaining pendency so that a continuation application of this case may be filed. Please charge the fee of \$2,160 for this extension to Deposit Account No. 50-1314.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By:

Laurence J. McClure

Lawrence J. McClure
Registration No. 44,228
Attorney for Applicant(s)

Date: October 25, 2005

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